



ISPlasma2017 / IC-PLANTS2017

9th International Symposium on Advanced Plasma Science
and its Applications for Nitrides and Nanomaterials /
10th International Conference on Plasma-Nano Technology & Science
Chubu University, Aichi, Japan, March 1-5, 2017

Best Presentation Award

in the area of Plasma Science

to

**GIICHIRO UCHIDA, TAIKI ITO, KOSUKE
TAKENAKA, JUNICHIRO IKEDA AND
YUICHI SETSUHARA**

“Measurements of the ROS and RNS in Liquid
Treated by a Nonthermal Plasma Jet”



Keiji Nakamura
Chairperson of ISPlasma2017 / IC-PLANTS2017 Organizing Committee
Professor of Chubu University



Masafumi Ito
Chairperson of ISPlasma2017 / IC-PLANTS2017 Program Committee
Professor of Meijo University